

# Search Notes



Application/Control No.

10/676,412

Examiner

José V. Chen

Applicant(s)/Patent under Reexamination

GIAMPAVOLO ET AL.

Art Unit

3637

## SEARCHED

Class	Subclass	Date	Examiner
108	5111	2/9/06	DL
	27		
	5511		
	5611		
206	386		
	600		
		10/3/14	DL
108	60		
211	1261		

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
Pat & back cut Pat location	2/9/06	DL
<del>SEARCHED</del>	<del>10/3/06</del>	<del>DL</del>